



Attorney Docket No. 069974-0143

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***IN THE UNITED STATES PATENT AND TRADEMARK OFFICE***

Applicant: Keiichiro KATA et al.  
Title: PROCESS FOR MANUFACTURING SEMICONDUCTOR DEVICE  
AND SEMICONDUCTOR WAFER  
Application No.: 10/645,782  
Filing Date: 8/22/2003  
Examiner: Mark Prenty  
Art Unit: 2822

**AMENDMENT AND REPLY UNDER 37 C.F.R. 1.173**

**Mail Stop Amendment**  
Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This amendment and reply is being filed in response to a final Office Action dated May 23, 2006, for the above-identified application.

**Amendments to the Claims** begin on page 2 of this document.

**Remarks/Arguments** begin on page 6 of this document.

Please amend the application as follows: